

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): MIZUMURA et al

Serial No.:

Filed: April 1, 2004

For: Etching Method Of Organic Insulating Film

**REAFFIRMATION OF CLAIM FOR PRIORITY**

Mail Stop: Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 1, 2004

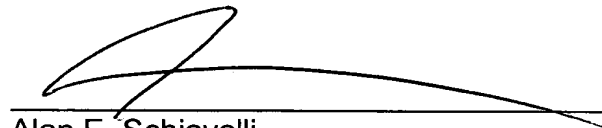
Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 2001-286052, filed in Japan on September 20, 2001.

The certified copy of the above-referred to Japanese Patent Application was filed on April 25, 2002 in prior application Serial No. 10/080,540, filed February 25, 2002.

Respectfully submitted,

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